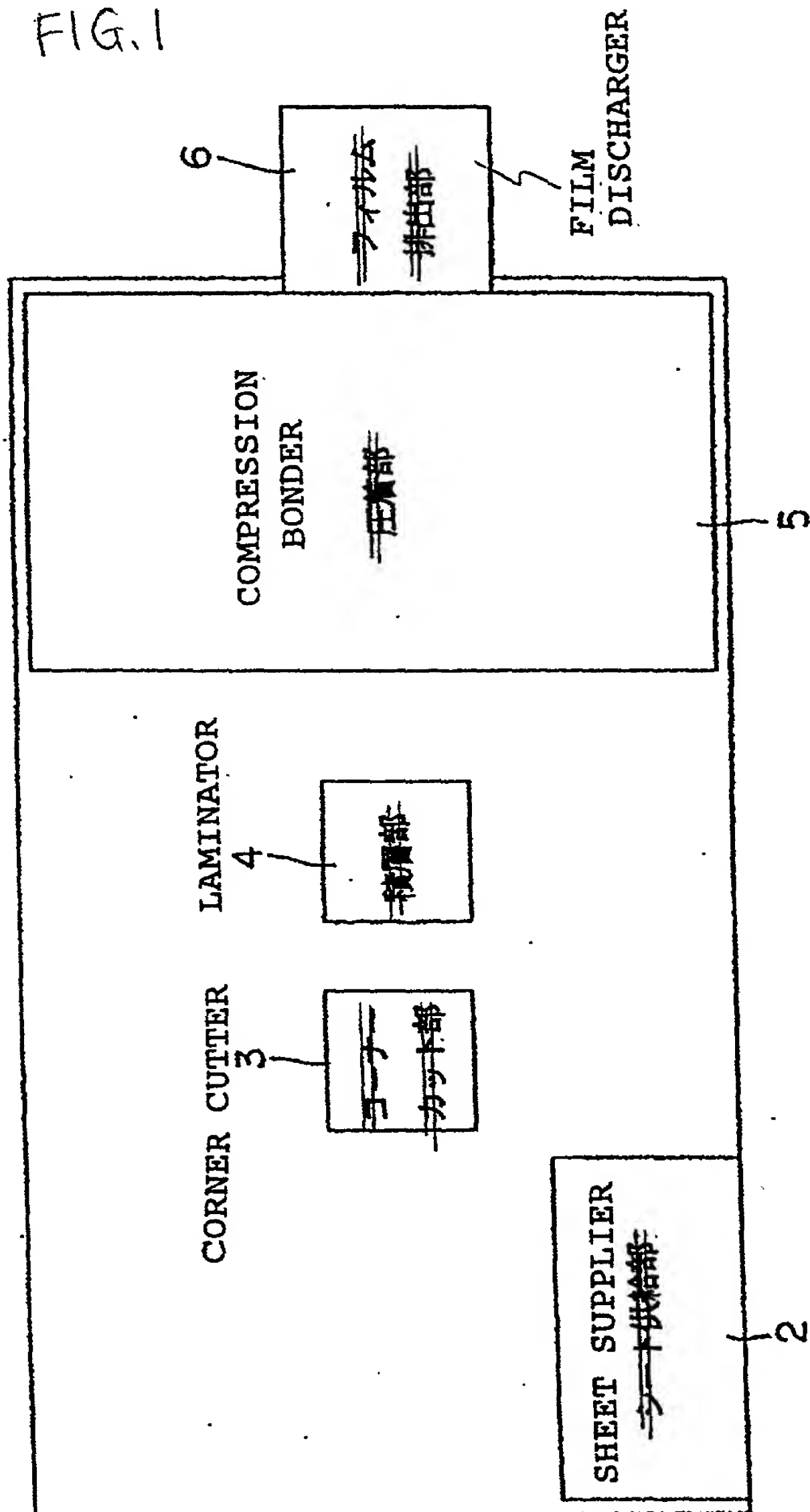


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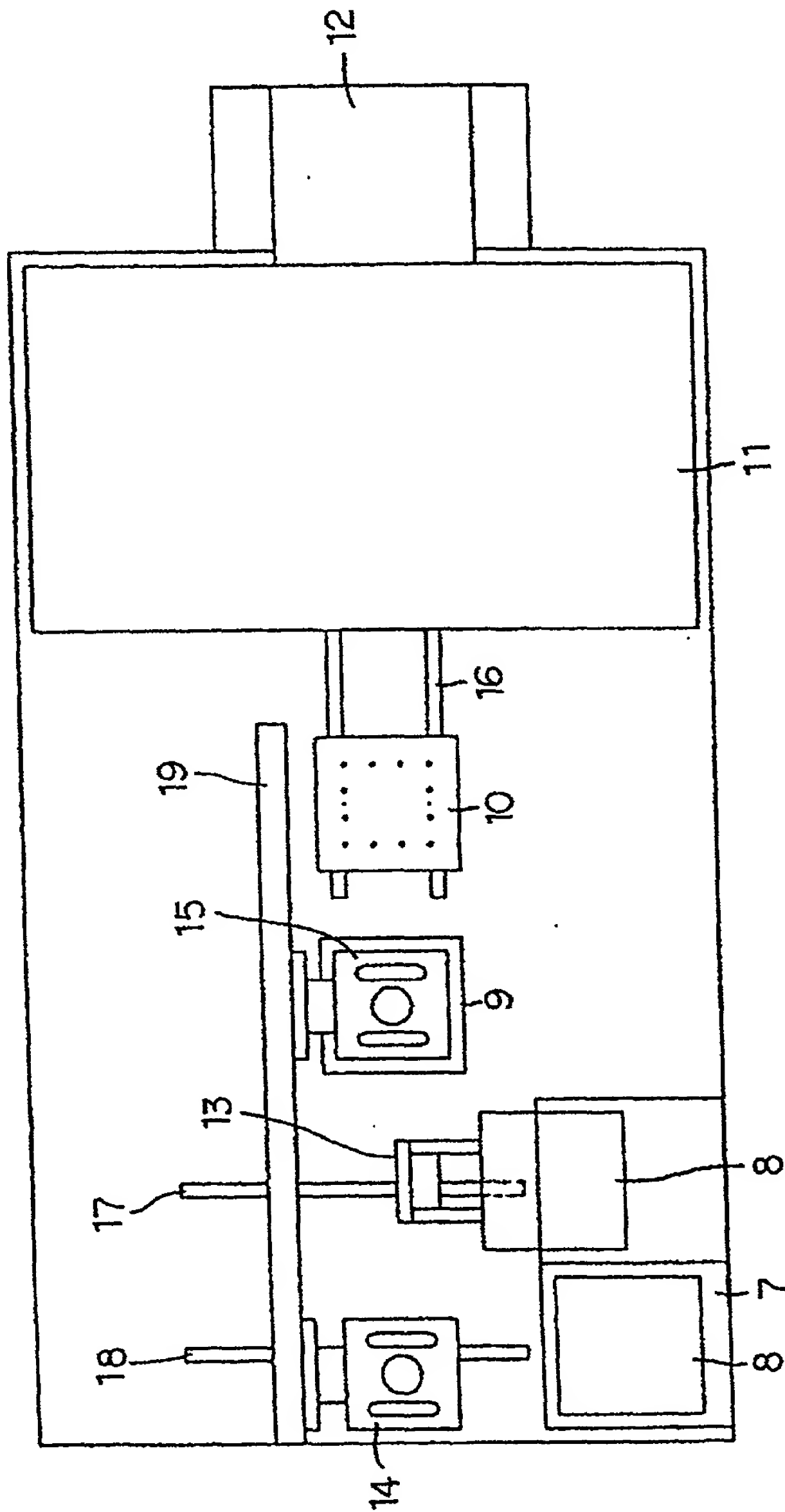
~~〔図面〕~~

~~〔図1〕~~ FIG.1

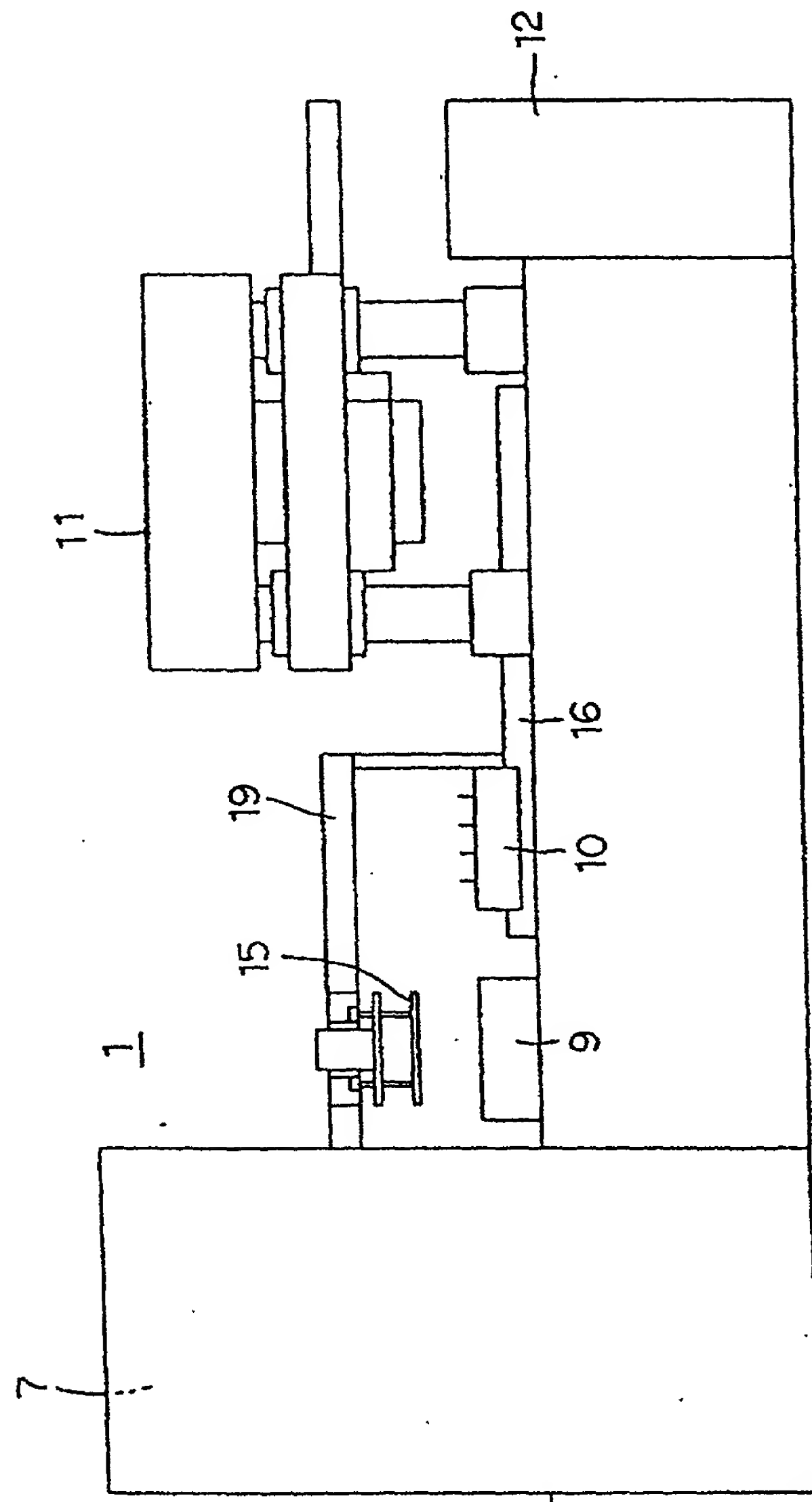


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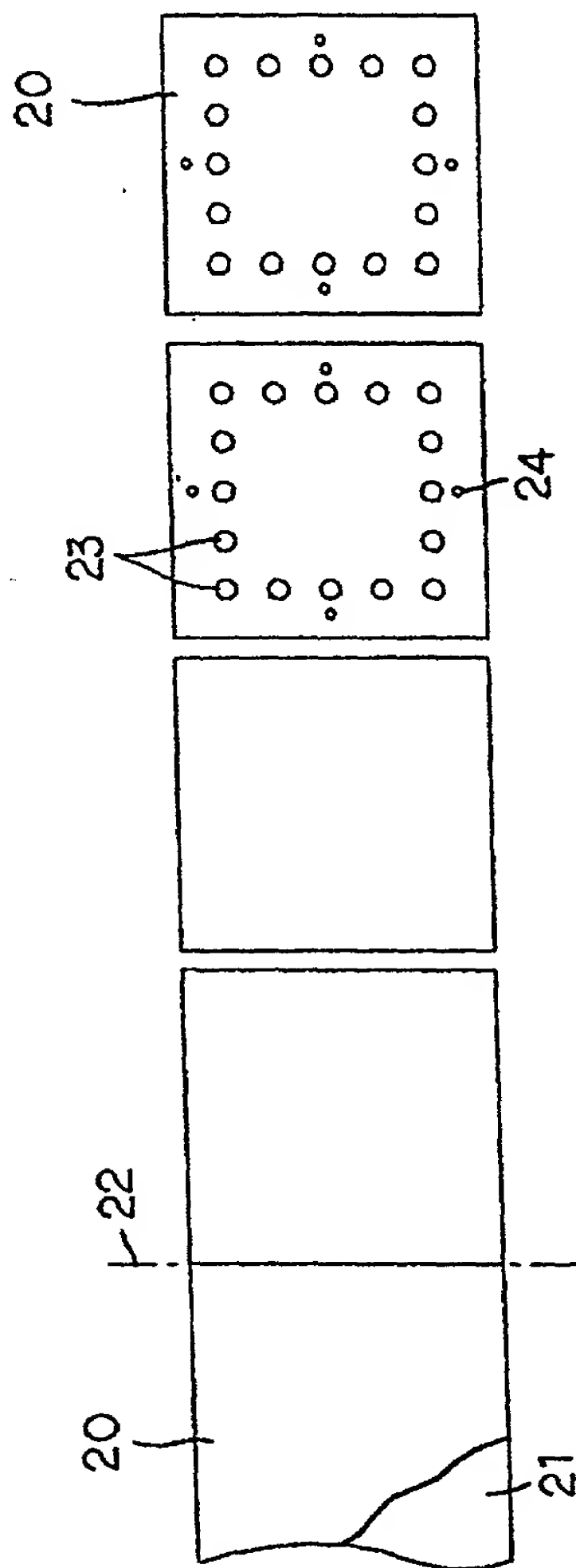
~~FIG. 2~~ FIG. 2



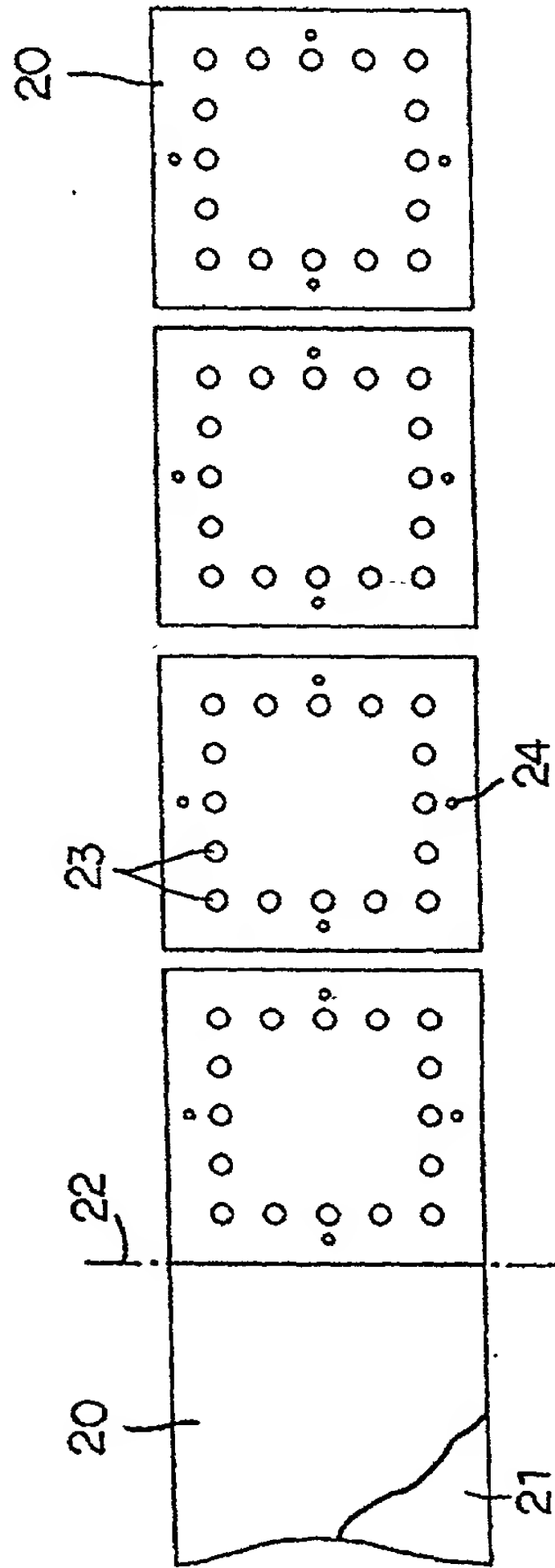
~~FIG. 3~~ FIG. 3



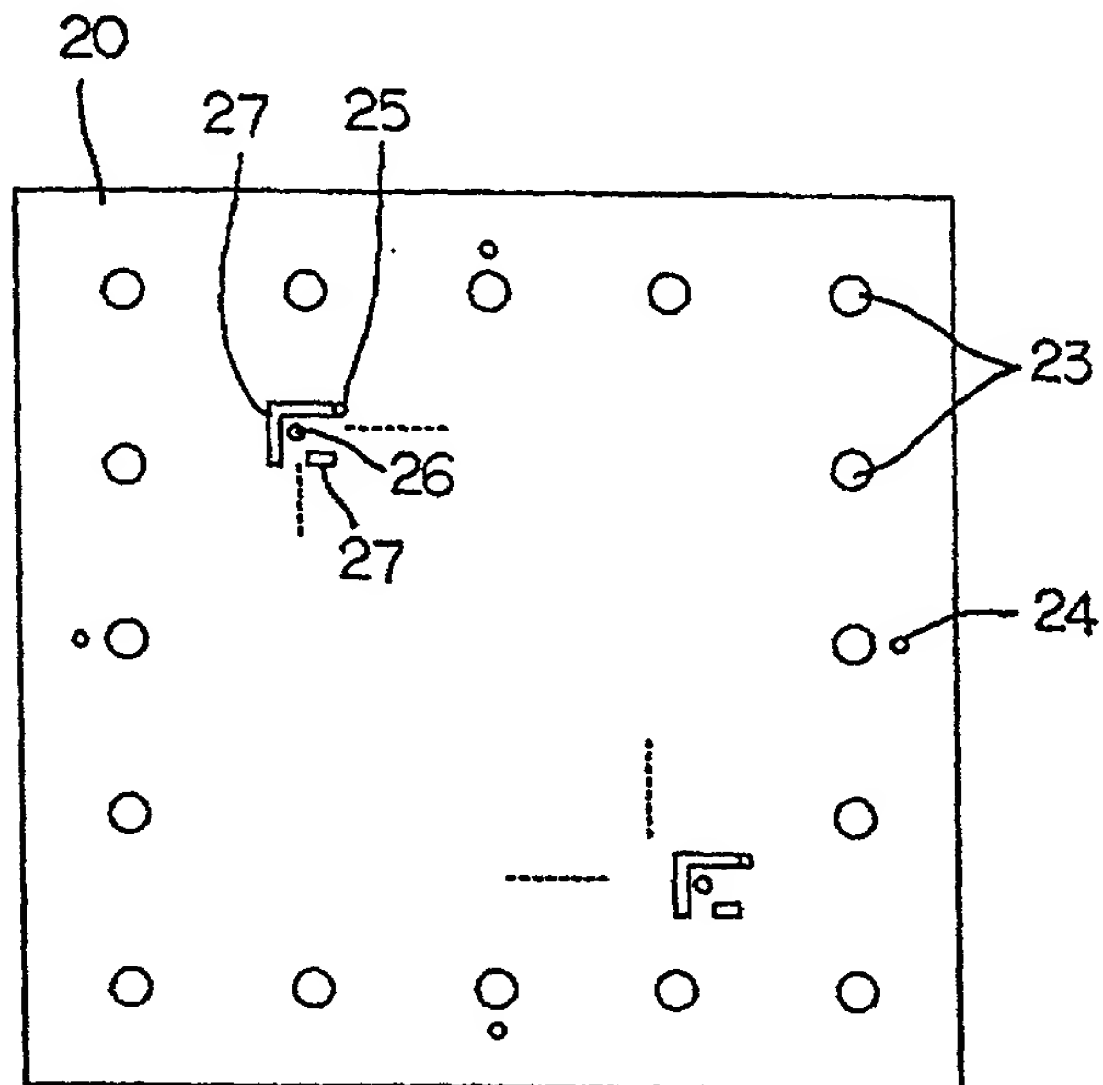
~~FIG. 4~~ FIG. 4



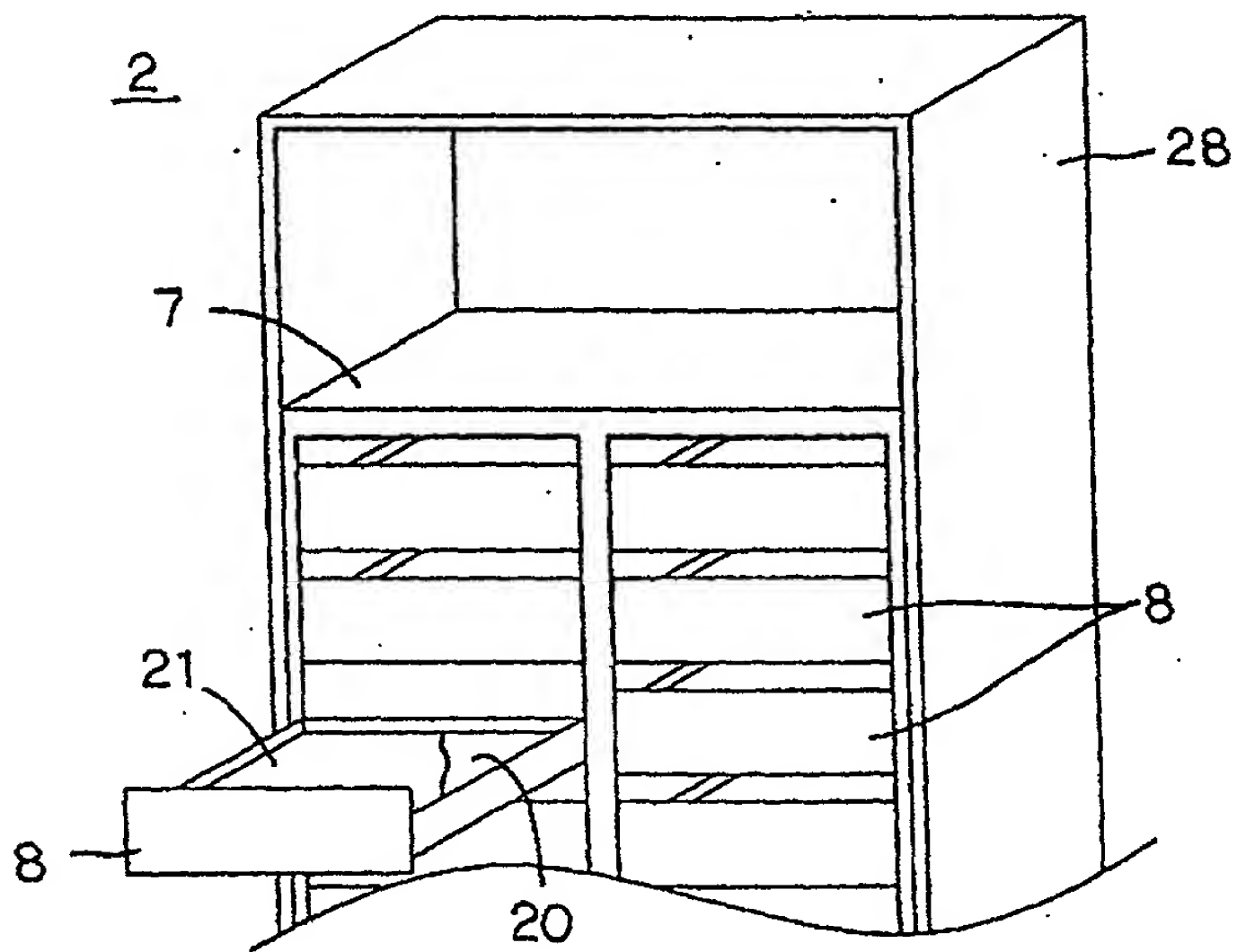
~~FIG. 5~~ FIG. 5



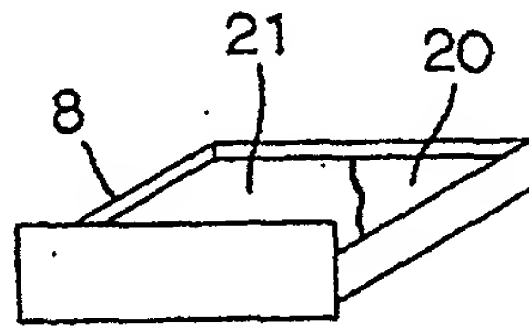
~~FIG. 6~~ FIG. 6



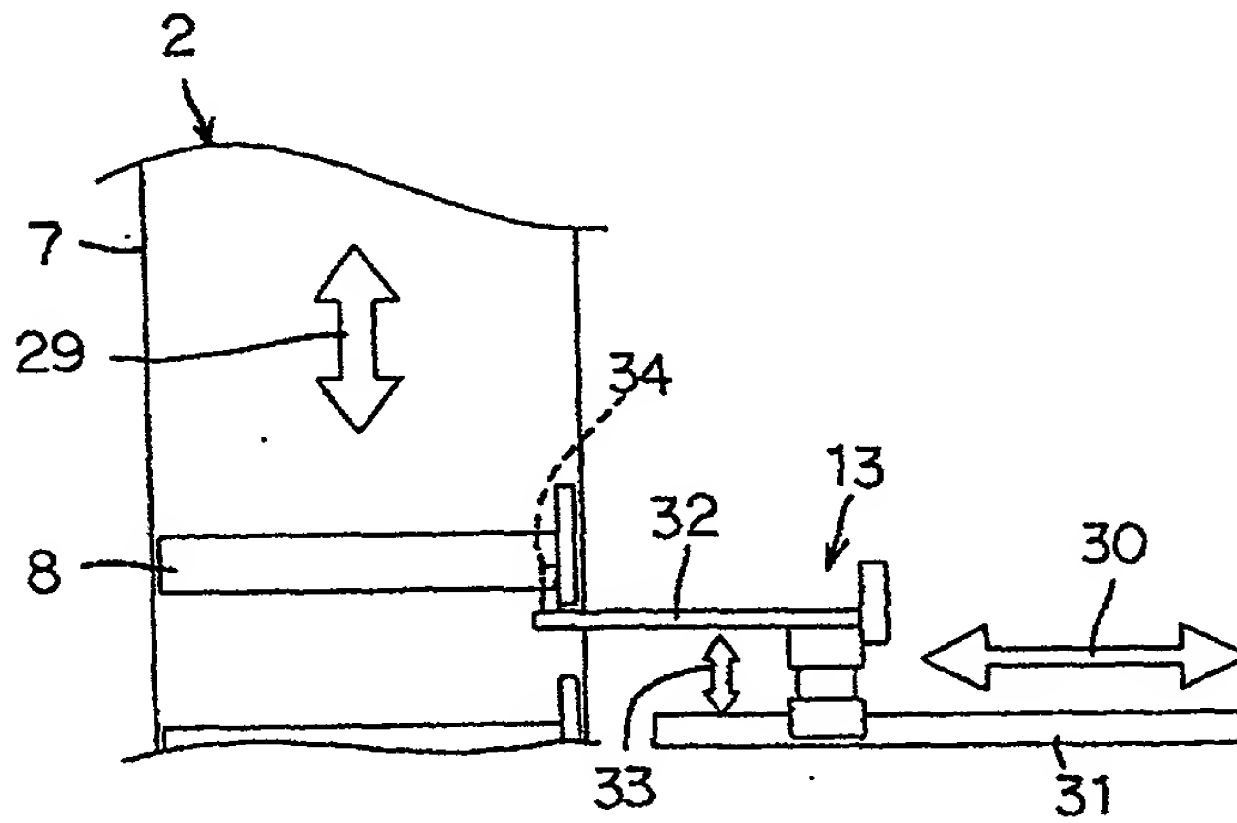
~~FIG. 7~~ FIG. 7



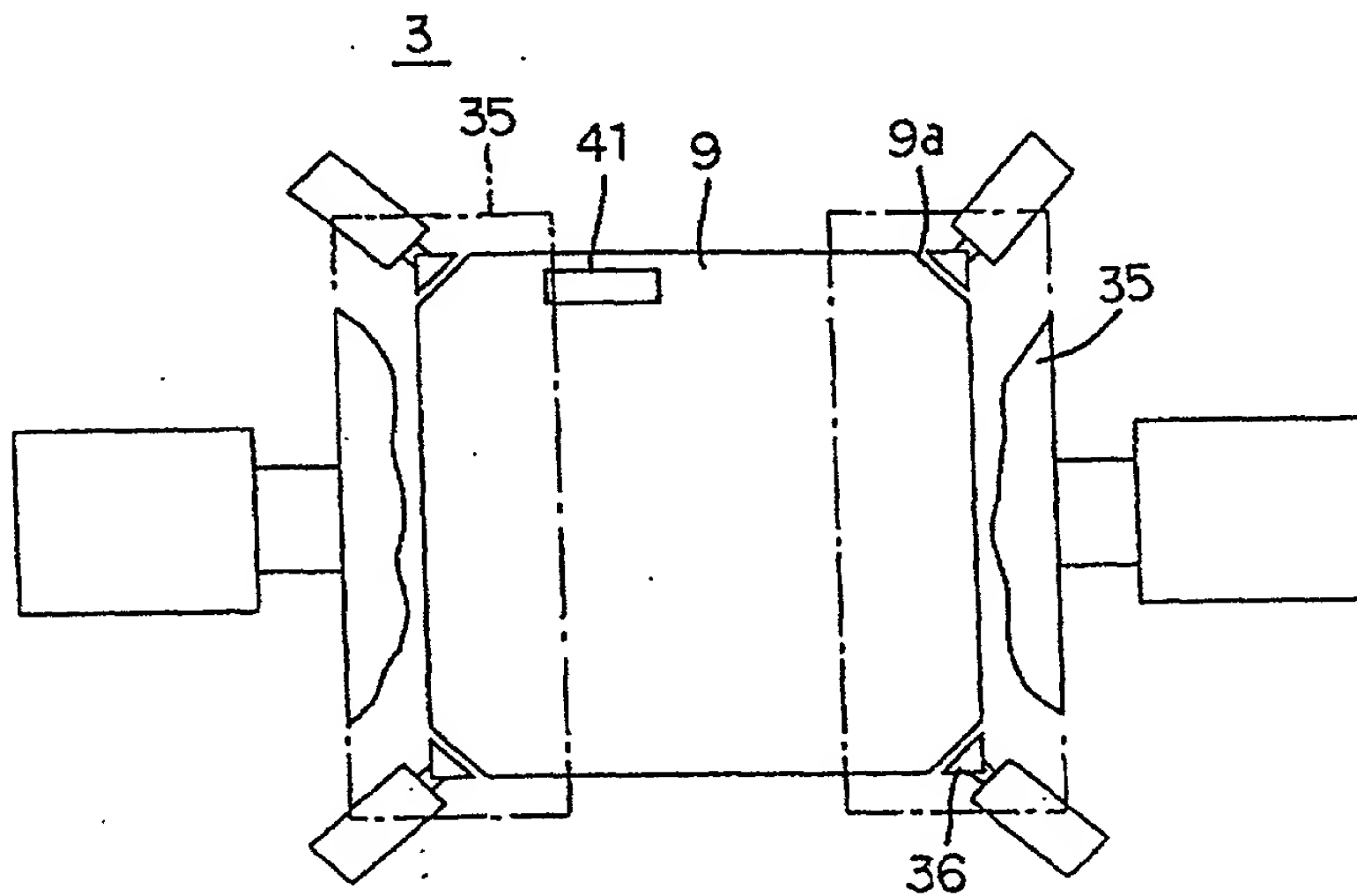
~~FIG. 8~~ FIG. 8



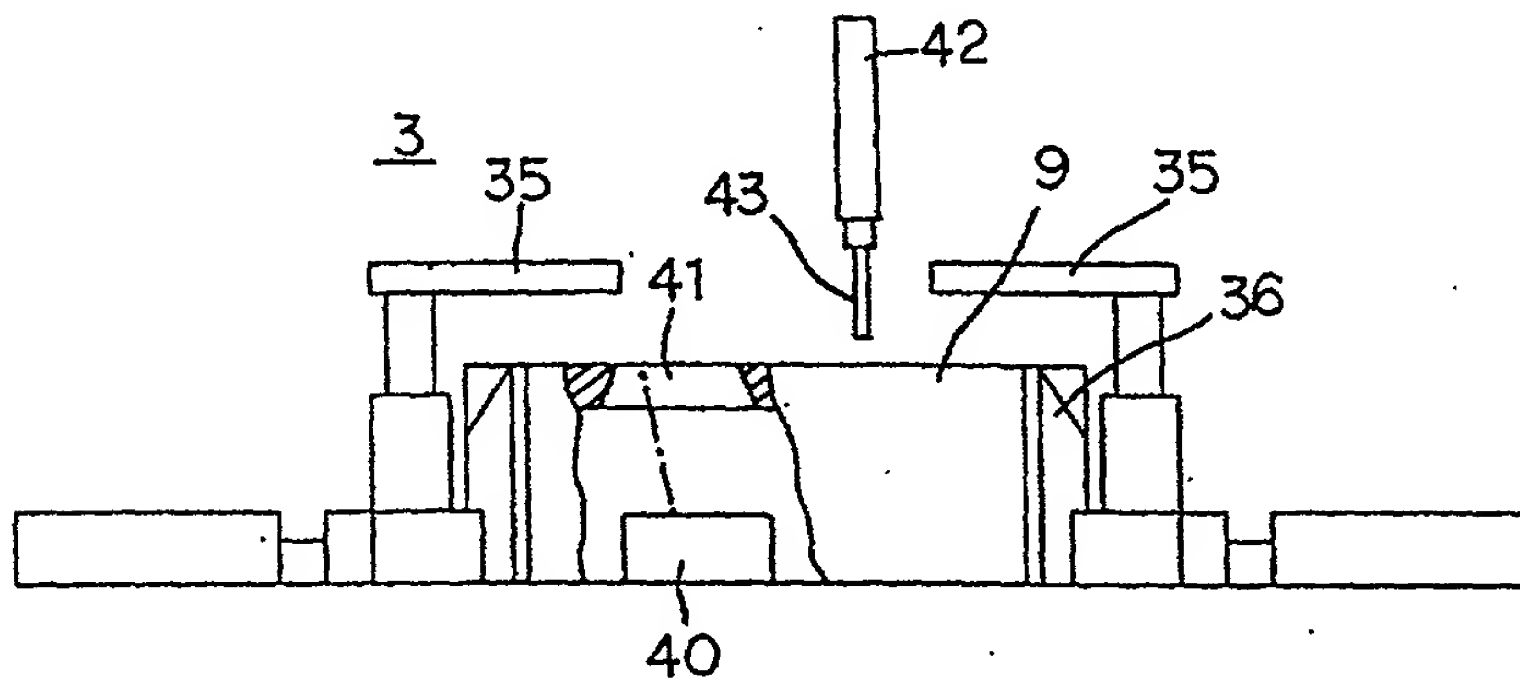
~~FIG. 9~~ FIG. 9



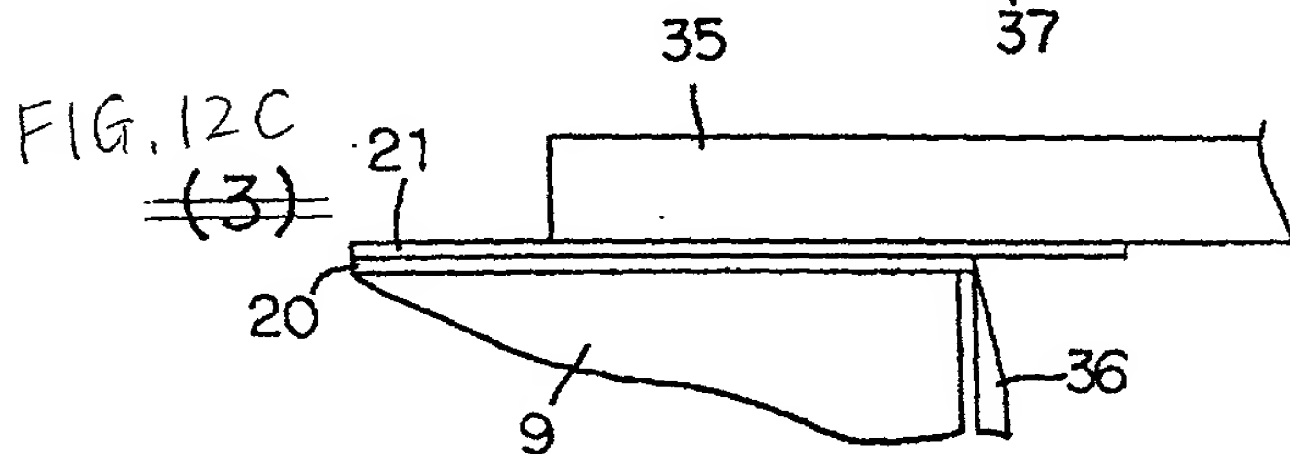
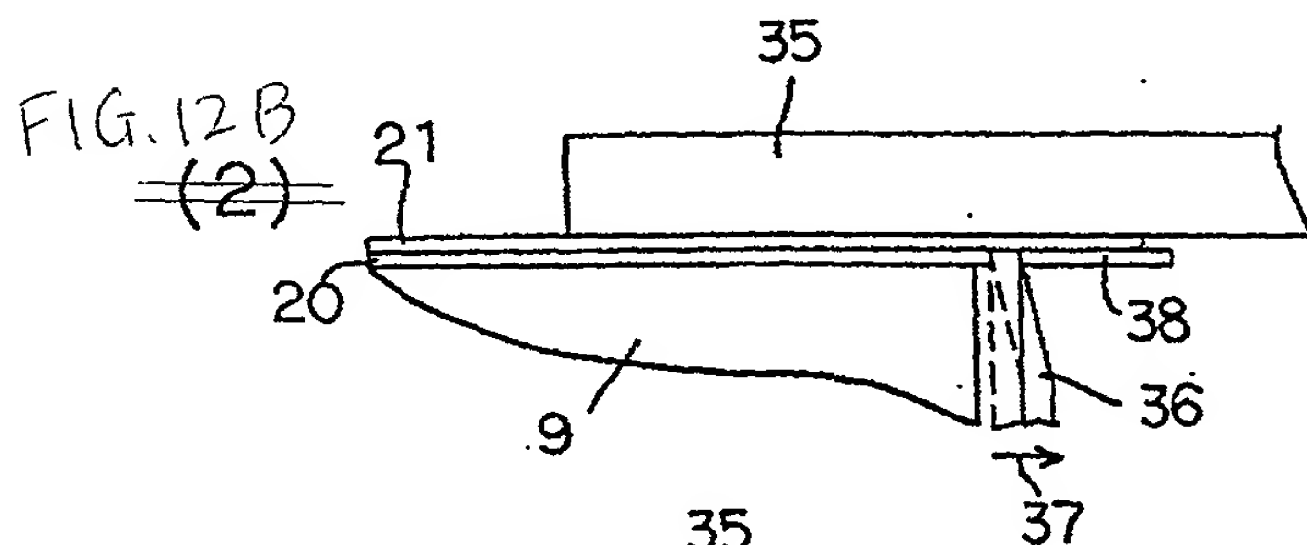
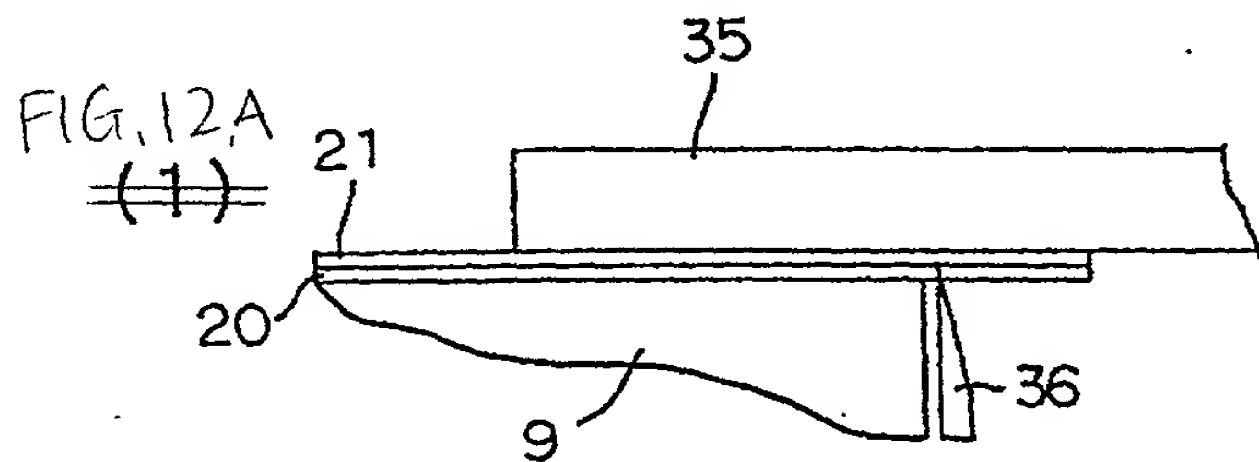
~~FIG. 10~~ FIG. 10



~~【図11】~~ FIG.11



~~【図12】~~



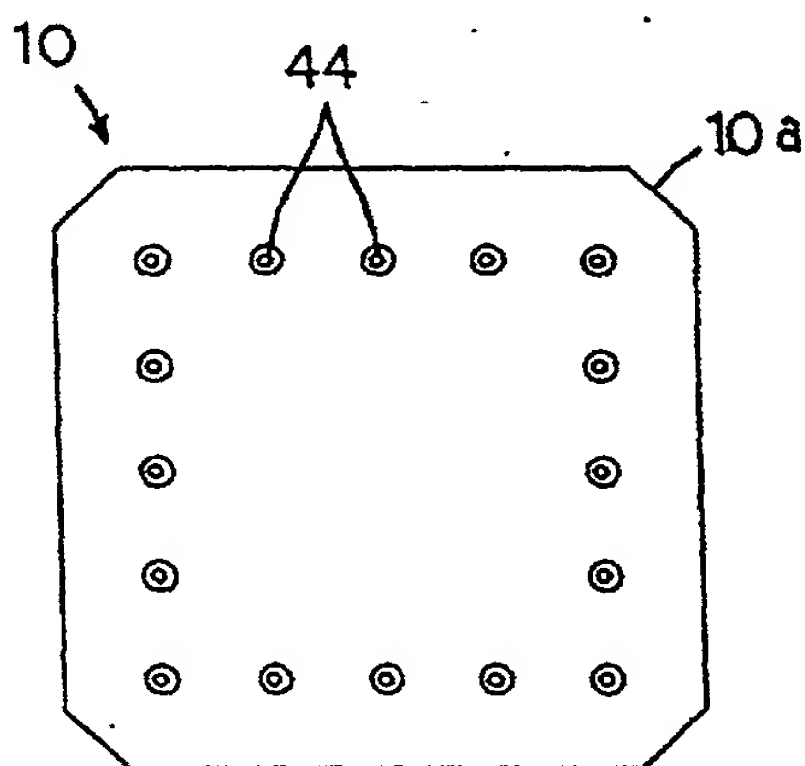


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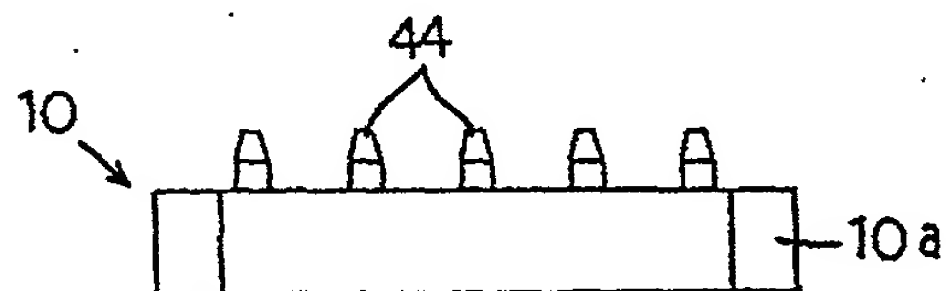
~~FIG. 13~~ FIG. 13



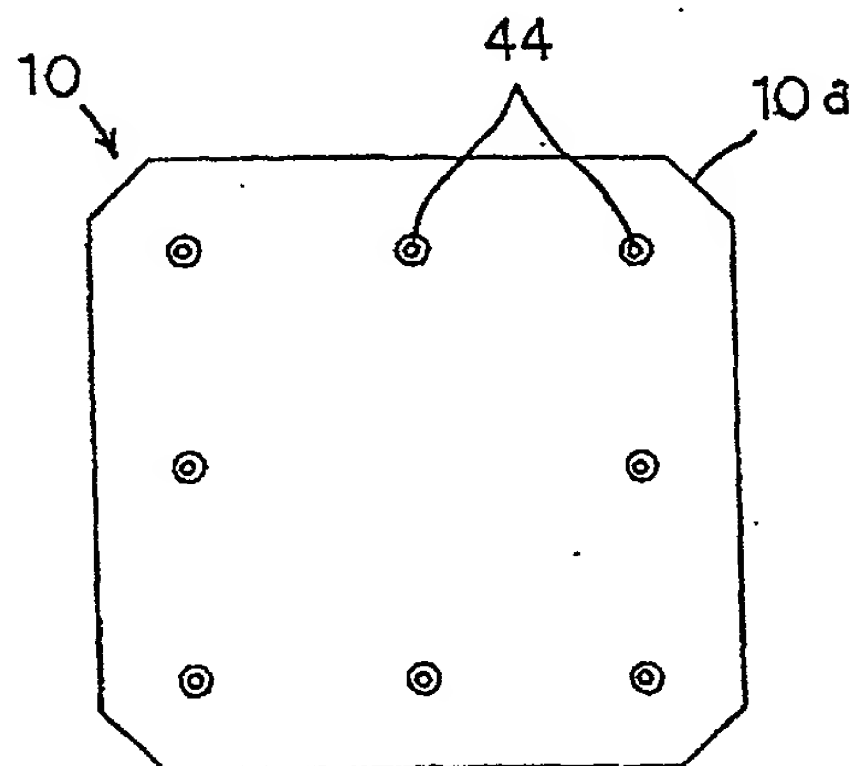
~~FIG. 14~~ FIG. 14



~~FIG. 15~~ FIG. 15



~~FIG. 16~~ FIG. 16



APPLN. FILING DATE: JUNE 29, 2001

TITLE: MANUFACTURING APPARATUS FOR MANUFACTURING

ELECTRONIC MONOLITHIC CERAMIC COMPONENTS

INVENTOR(S): MASATOSHI ARISHIRO, ET AL.

APPLICATION SERIAL NO: UNASSIGNED

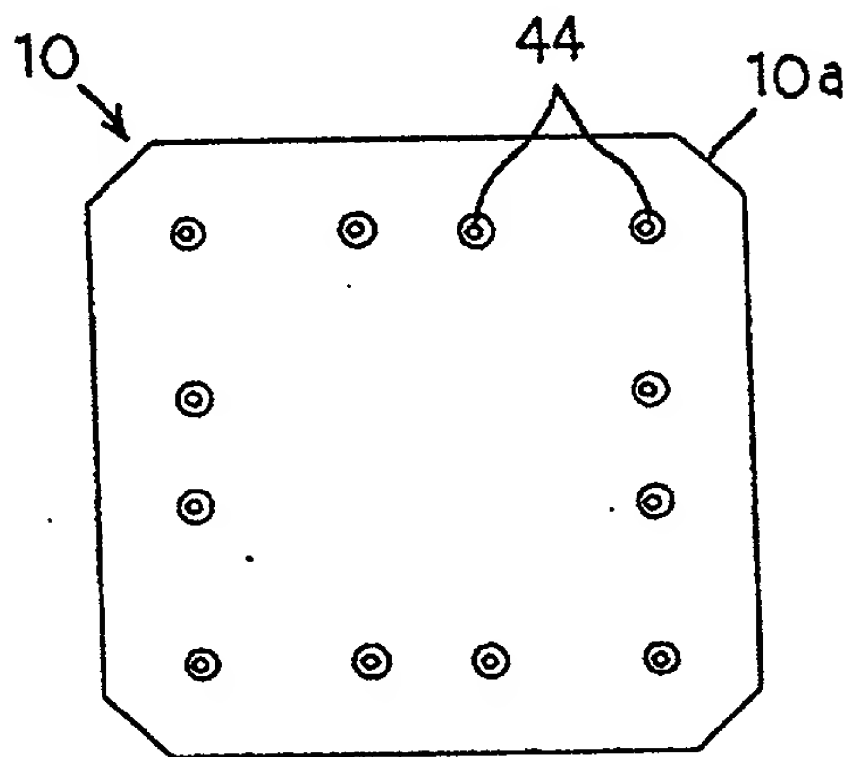
SHEET 10 of 13

提出日 平成 12 年 7 月 31 日

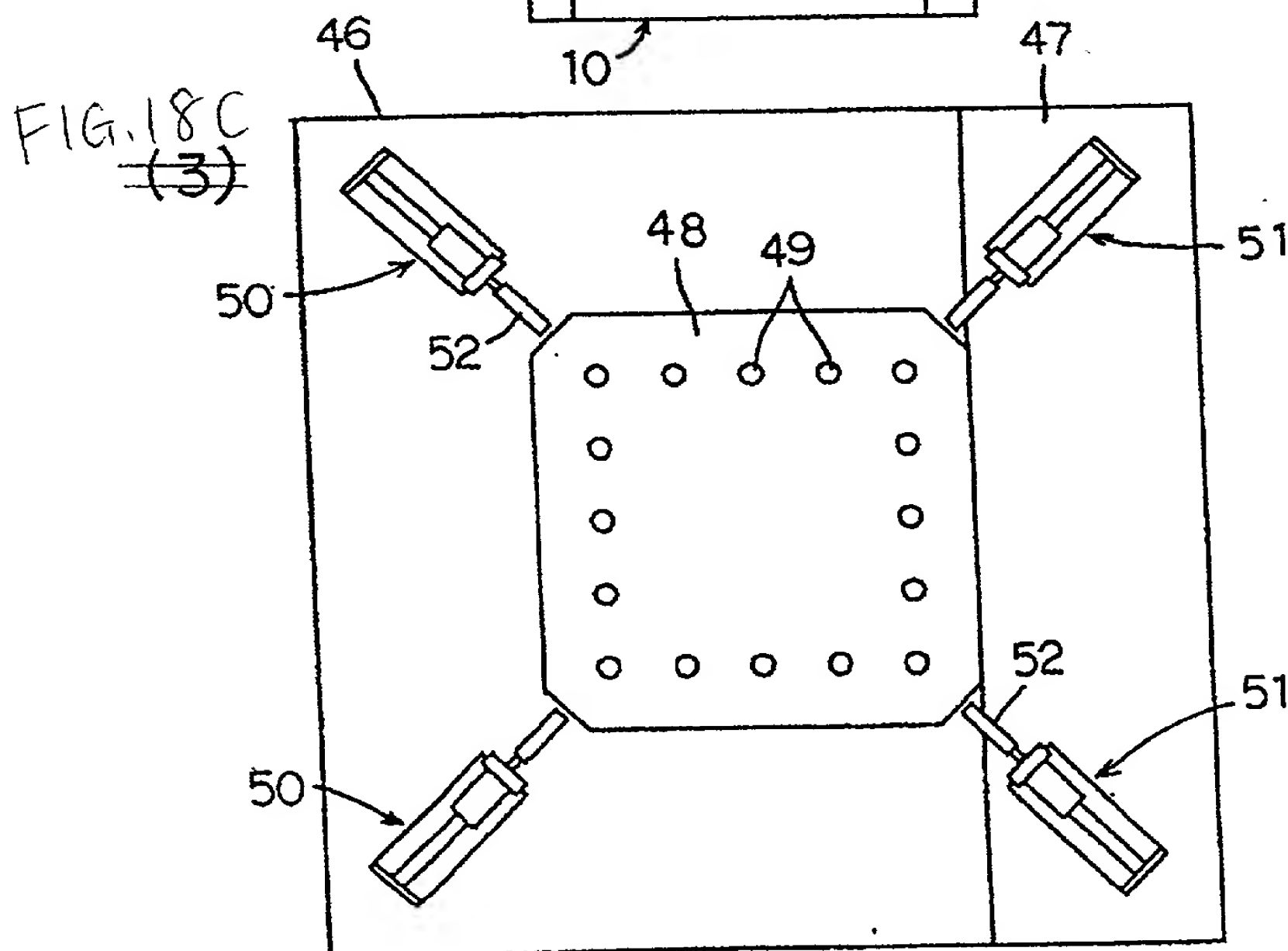
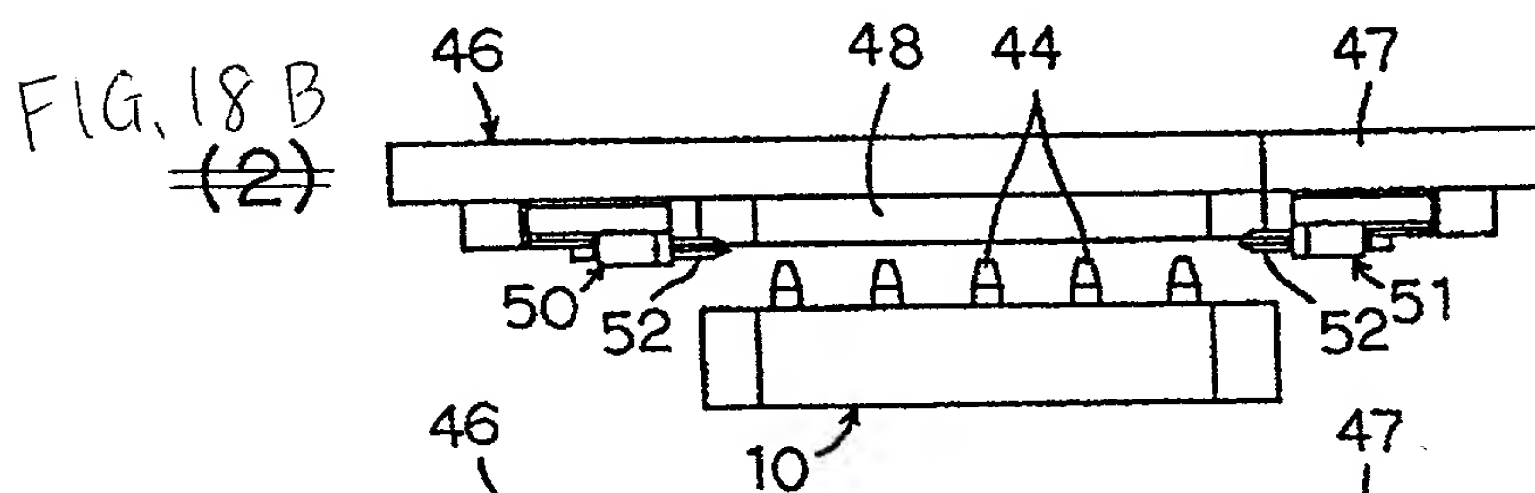
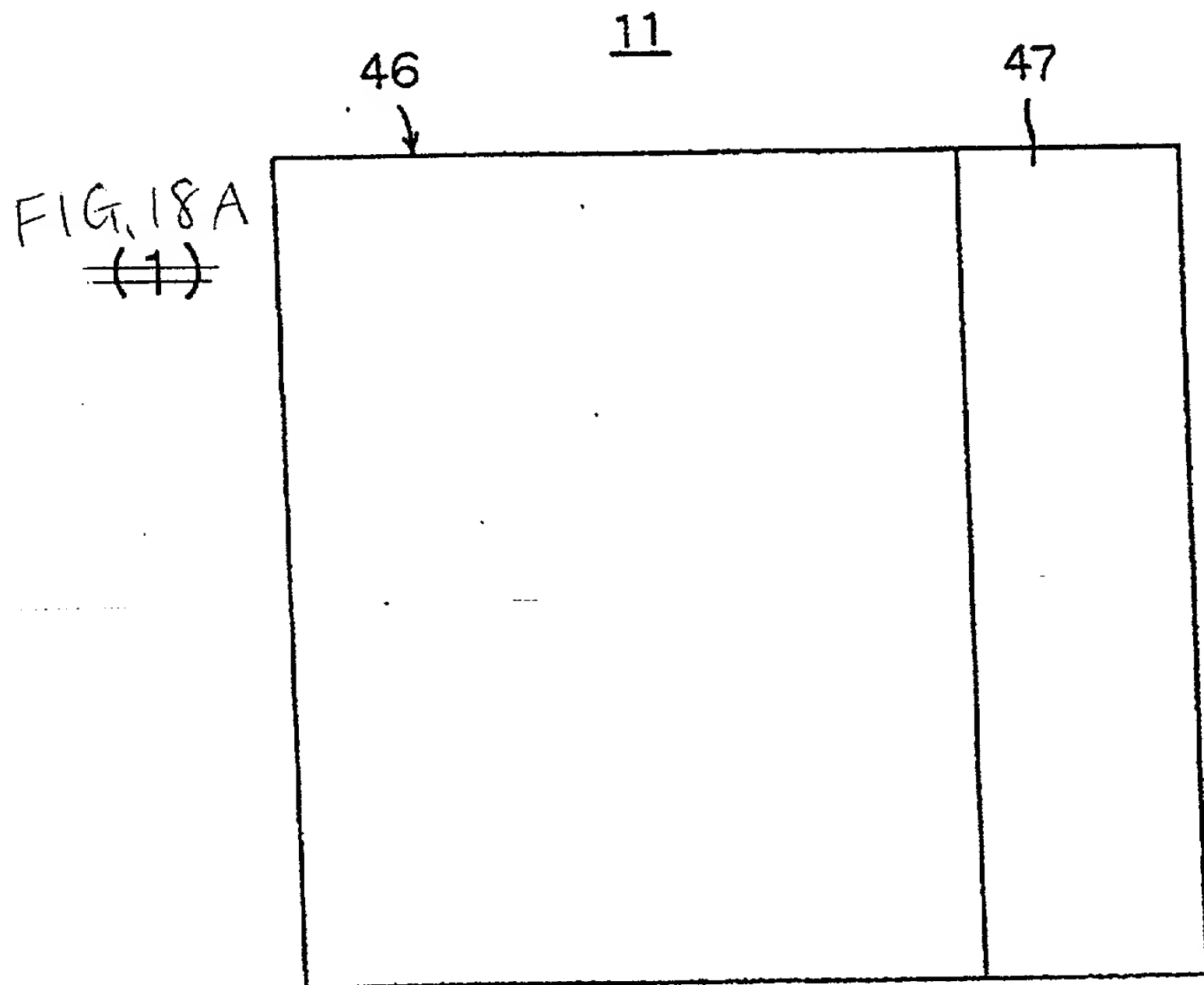
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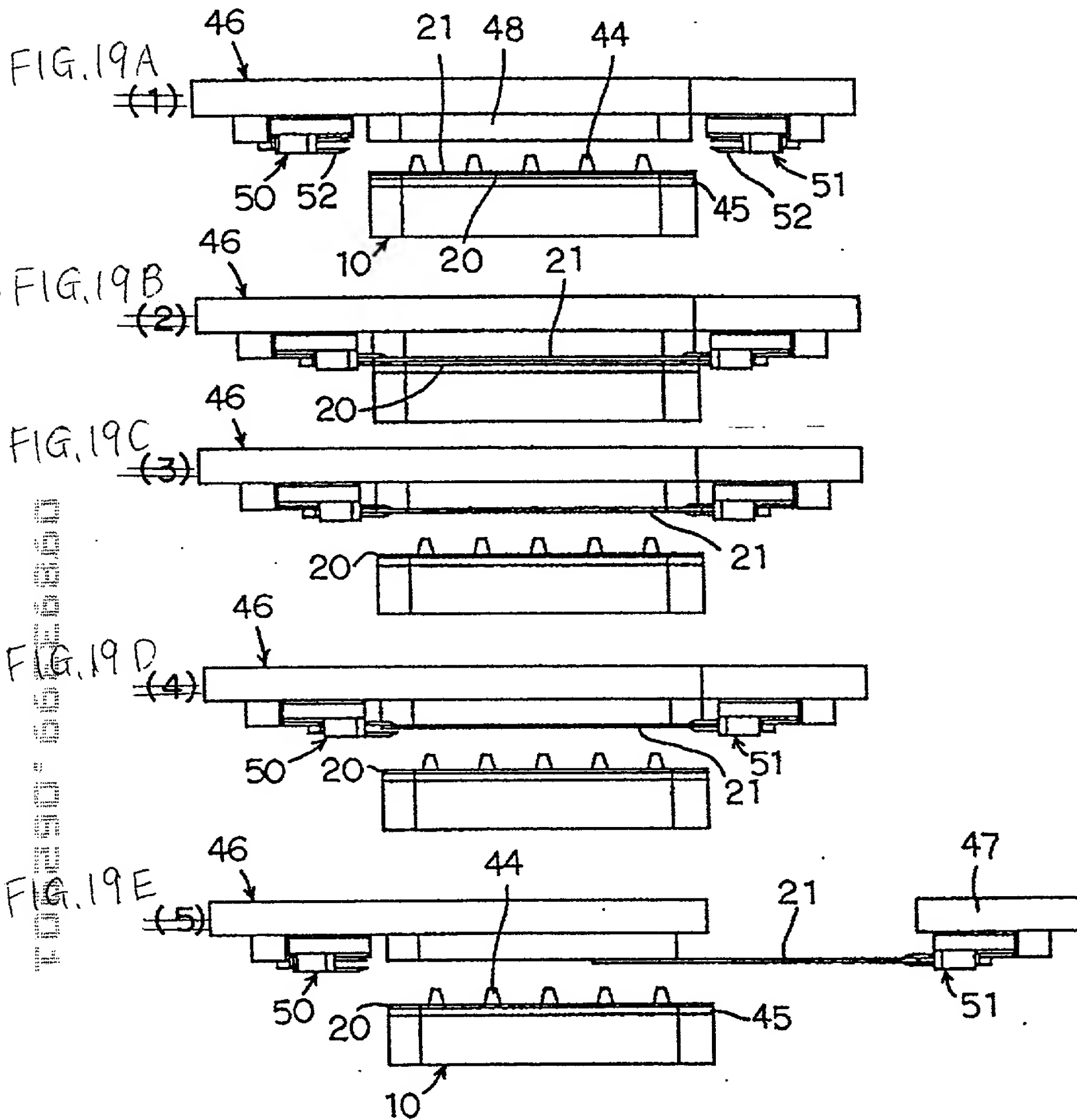
~~【図 17】~~ FIG. 17



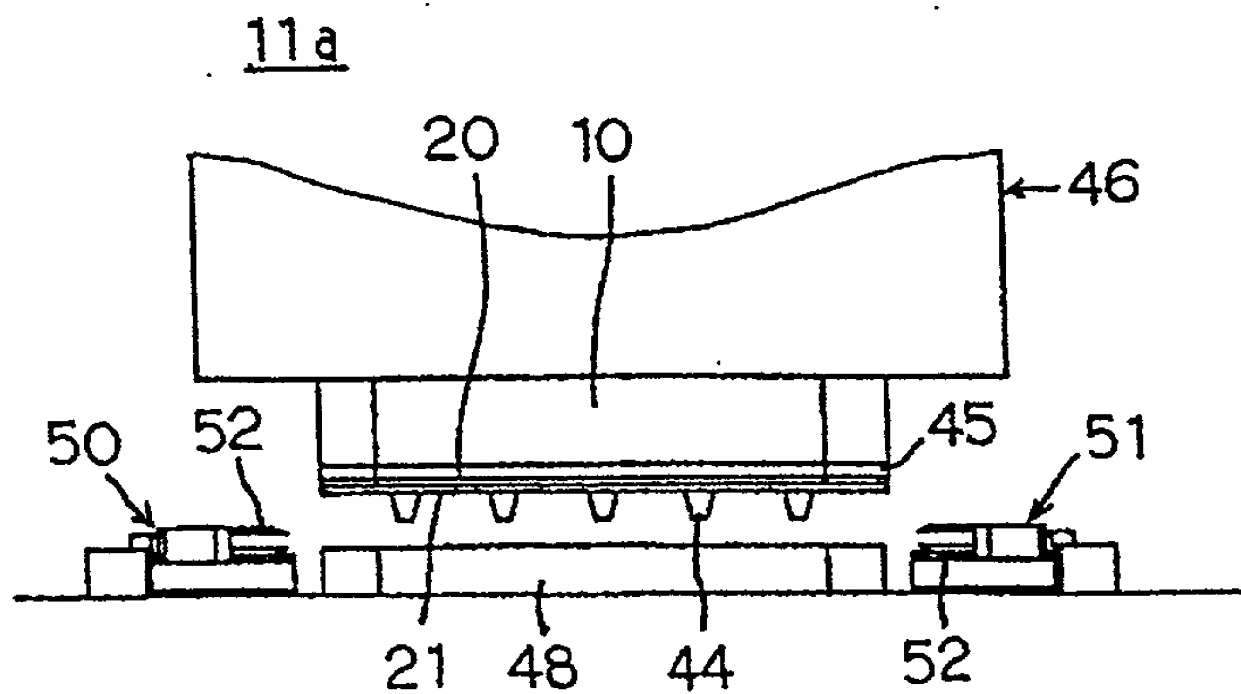
~~〔図 1-8〕~~



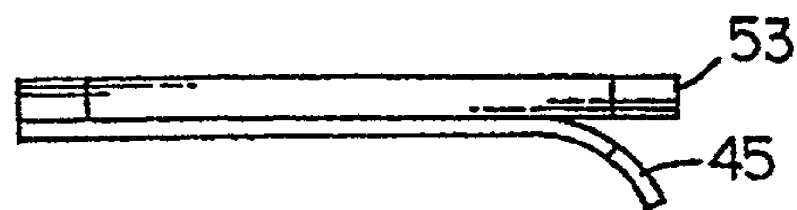
~~[図19]~~



~~[図20]~~ FIG. 20



~~FIG. 21~~ FIG. 21



~~FIG. 22~~ FIG. 22

